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U.S. Patent Application Serial No. 09/811,106

ATMI-513

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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

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**APR 21 2004**

**In re United States Patent Application of:**

**Applicants: Ravi K. Laxman, et al.**

**Group Art Unit: 1621**

**Serial No.: 09/811,106**

**Examiner: Samuel A. Barts**

**Date Filed: March 17, 2001**

**Confirmation Number: 9357**

**Title: Low Dielectric Constant Thin Films and  
Chemical Vapor Deposition Method of Making  
Same**

**Customer No.: 25559**

**FACSIMILE TRANSMISSION CERTIFICATE**

It hereby is certified by the person identified below that this paper is being facsimile transmitted by such person to the Commissioner of Patents and Trademarks on the date specified, to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, and Transmitted by Facsimile under the provisions of 37 CFR 1.6(d).

  
Maggie Chappuis

April 21, 2004  
Date of Transmission

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**AMENDMENT RESPONDING TO OCTOBER 21, 2003 OFFICE ACTION IN  
U.S. PATENT APPLICATION NO. 09/811,106 AND PETITION FOR THREE  
MONTH EXTENSION OF TIME UNDER 37 C.F.R. § 1.136**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

U.S. Patent Application Serial No. 09/811,106

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In response to the Office Action dated October 21, 2003, applicant respectfully requests entry of the following Amendments and consideration of the subsequent remarks.